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Practitioner's Docket No. OGW-0043

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Haruhiko HIROSUE et al.

Application No.: 09/926,143

Group No.: 1732

Filed: September 10, 2001

For: MANUFACTURING METHOD AND APPARATUS FOR OPEN TYPE POLYIMIDE MOLDING PRODUCT, AS WELL AS A REFLECTOR SUBSTRATE FOR USE IN ILLUMINATION EQUIPMENT

Attention: Office of Initial Patent Examination's
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REQUEST FOR CORRECTED FILING RECEIPT

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested. Also enclosed is a copy of the Declaration that was filed.

2. There is an error with respect to the following, which is incorrectly entered.

Error In

Correct data

1. Title

1. MANUFACTURING METHOD AND APPARATUS FOR OPEN TYPE POLYIMIDE MOLDING PRODUCT, AS WELL AS A REFLECTOR SUBSTRATE FOR USE IN ILLUMINATION EQUIPMENT

3. The correction is not due to any error by applicant and no fee is due. However, if any costs are involved, please charge Deposit Account No. 18-0013.

Dated: 12/3/01

Tel. No.: (202) 955-3750

Carl Schaukowitz
Reg. No. 29,211
Rader, Fishman & Grauer, PLLC
Suite 501
1233 20th Street, N.W.
Customer No.: 23353



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/926,143	09/10/2001	1732	1220	P100158-00043	4	25	1

CONFIRMATION NO. 9383

004372

ARENT FOX KINTNER PLOTKIN & KAHN
1050 CONNECTICUT AVENUE, N.W.
SUITE 600
WASHINGTON, DC 20036

FILING RECEIPT



OC000000006961662

Date Mailed: 10/26/2001

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Applicant(s)

Haruhiko Hirose, Yamagata, JAPAN; ✓
Shigeo Shibata, Yamagata, JAPAN; ✓
Hideaki Machida, Tokyo, JAPAN; ✓

Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/JP01/00127 01/12/2001 ✓

Foreign Applications

JAPAN 2000-4209 01/13/2000

Projected Publication Date: To Be Determined - pending completion of Security Review

Non-Publication Request: No

Early Publication Request: No

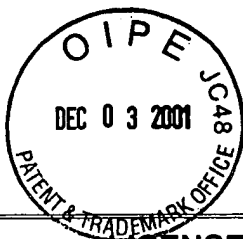
Title

Manufacturing Method and Apparatus for Opentype Polymide
Molding Products, as well as a reflector Substrate for
Method and device for producing open type polymide moldings, and base material for use in
reflective bodies in lighting equipment

Illumination Equipment

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Preliminary Class
264



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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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